



Sheet 1 of 1

FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)

Date Submitted to PTO: February 20, 2001

ATTY DOCKET NO.

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APPLICATION NO.

09/708,590

APPLICANT

MASATO MURAKI, ET AL.

FILING DATE

November 9, 2000

GROUP

2881

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KF	6,137,113	10/2000	Muraki	250	492.22	
	6,124,599	09/2000	Muraki	250	492.22	
	6,107,636	08/2000	Muraki	250	492.2	
	6,104,035	08/2000	Muraki	250	492.22	
	6,054,713	04/2000	Miyake, et al.	250	492.24	
	5,981,954	11/1999	Muraki	250	397	
	5,929,454	07/1999	Muraki, et al.	250	491.1	
KP	5,905,267	05/1999	Muraki	250	492.22	

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT

## OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

KF	M. Parikh, "Corrections to Proximity Effects in Electron Beam Lithography", <u>J. Appl. Phys.</u> , 50(6), June 1979, page 4371 through page 4377.
KF	J.M. Pavkovich, "Proximity Effect Correction Calculations by the Integral Equation Approximate Solution Method", <u>J. Vac. Sci. Technol.</u> , B4(1), Jan/Feb 1986, page 159 through page 163.

EXAMINER

DATE CONSIDERED

3-20-02

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.